

2815

AF



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**BOX AF**

**RESPONSE AFTER FINAL  
EXPEDITED PROCEDURE  
EXAMINING GROUP 2815**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

KIMURA

Art Unit: 2815

Application No. 09/805,102

Examiner: J. Nguyen

Filed: March 14, 2001

Attorney Dkt. No.: 107400-00026

For: SEMICONDUCTOR LASER

**AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116**

**BOX AF**

Commissioner for Patents  
P.O. Box 1450  
Arlington, VA 22313-1450

June 19, 2003

Sir:

In reply to the Office Action dated March 19, 2003, please amend the above-identified application as follows:

9/13  
7/19  
JN  
8/5/3

RECEIVED  
JUN 23 2003  
TECHNOLOGY CENTER 2800